

Amendments to the Specification

Please replace paragraphs [0030] through [0036] with the following amended paragraphs:

[0030] These and other objects of the invention are achieved by the rotationally mergeable MEMS apparatus comprising the combination of:

[0031] an electronic circuit module having a MEMS active element controlling output electrode disposed in an upper layer output location thereof;

[0032] a mating MEMS active element module having an electromagnetic field movable active element disposed in an exposed, said output electrode corresponding, location thereof, said MEMS active element module including module supporting flexible tensile members connected with a substrate hinge-mounted sacrificial MEMS active element module support element; and

[0033] a MEMS active element module physical support element latching member movably mounted on said substrate and disposable in a position of mutually locked engagement with said substrate hinge mounted MEMS active element module support element in a selected off-chip and rotated about said hinge location thereof adjacent said electronic circuit module.